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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

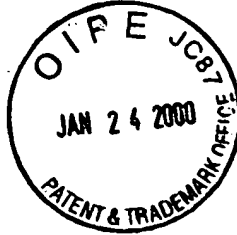
In Re Application of:

Wu et al.

Serial No.: 09/132,876

Filed: August 11, 1998

For: Chemical-Mechanical Polishing Method



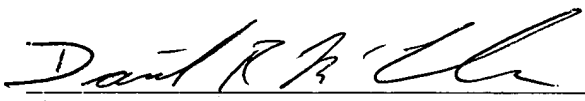
Group Art Unit: 1765

Examiner: K. Chen

Docket No.: 252103-2040

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington D.C. 20231, on January 20, 2000.


Signature

SUBMISSION OF SUBSTITUTE DRAWINGS

Assistant Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

Please substitute the enclosed drawings for the drawings originally filed in this application. The enclosed drawings are identical photocopies of the original drawings filed in this application.

The Applicants were advised in an Office Action mailed November 17, 1999 (Paper No. 3), that the drawings were not present. However, and as Applicants verified in connection with

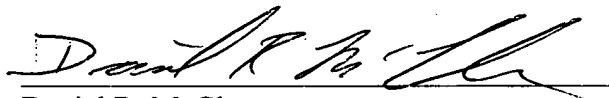
their response to the Office Action, the accompanying four drawing sheets were presented with the originally-filed application.

No fee is believed to be due in connection with this Submission of Substitute Drawings. If, however, any fees are required, any such fees are hereby authorized to be charged to our Deposit Account No. 20-0778.

Respectfully submitted,

**THOMAS, KAYDEN, HORSTEMEYER
& RISLEY, L.L.P.**

By:



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